



70 AF

PATENT
8040-1052

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Taishi KUBOTA et al.

Conf. 8011

Application No. 10/763,244

Group 2823

Filed January 26, 2004

Examiner Trung Q. Dang

MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE
AND OXIDIZATION METHOD OF SEMICONDUCTOR
SUBSTRATE

RESPONSE AFTER FINAL REJECTION

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 16, 2006

Sir:

This responds to the Official Action mailed May 17,
2006.

Remarks begin on page 2 of this paper.